

L Number	Hits	Search Text	DB	Time stamp
9	101	gap adj gauge	USPAT; JPO	2003/02/10 11:02
10	228	distance adj gauge	USPAT; JPO	2003/02/10 11:02
11	689372	chamber	USPAT; JPO	2003/02/10 11:03
12	0	(gap adj gauge) and (distance adj gauge) and chamber	USPAT; JPO	2003/02/10 11:03
13	48615	chuck	USPAT; JPO	2003/02/10 11:04
14	52260	chuck	USPAT; US-PGPUB; JPO	2003/02/10 11:05
15	1466	chuck and (vacuum adj chamber)	USPAT; US-PGPUB; JPO	2003/02/10 11:05
16	0	(chuck and (vacuum adj chamber)) and ((gap or distance)adj gauge)	USPAT; US-PGPUB; JPO	2003/02/10 11:06
17	53	semiconductor adj chamber	USPAT; US-PGPUB; JPO	2003/02/10 11:07
18	14	chuck and (semiconductor adj chamber)	USPAT; US-PGPUB; JPO	2003/02/10 11:11
19	4	CVD or RTCVD)and((gap or distance) adj gauge	USPAT; US-PGPUB; JPO	2003/02/10 11:16
20	40934	vacuum adj chamber	USPAT; US-PGPUB; JPO	2003/02/10 11:16
21	1466	(vacuum adj chamber) and chuck	USPAT; US-PGPUB; JPO	2003/02/10 11:17
22	0	((vacuum adj chamber) and chuck) and (gap adj gauge)	USPAT; US-PGPUB; JPO	2003/02/10 11:33
23	0	((vacuum adj chamber) and chuck) and (distance adj gauge)	USPAT; US-PGPUB; JPO	2003/02/10 11:18
24	10	((vacuum adj chamber) and chuck) and (measure adj gap)	USPAT; US-PGPUB; JPO	2003/02/10 11:18
25	5	((vacuum adj chamber) and chuck) and (measure adj distance)	USPAT; US-PGPUB; JPO	2003/02/10 11:30
26	8	((vacuum adj chamber) and chuck) and (gap adj sensor)	USPAT; US-PGPUB; JPO	2003/02/10 11:37
27	10098	baffle adj plate	USPAT; US-PGPUB; JPO	2003/02/10 11:37
28	310	(baffle adj plate) and (chamber adj wall)	USPAT; US-PGPUB; JPO	2003/02/10 11:39
29	0	((baffle adj plate) and (chamber adj wall)) and ((gap or distance)adj(sensor or gauge))	USPAT; US-PGPUB; JPO	2003/02/10 11:39
30	37	((baffle adj plate) and (chamber adj wall)) and gauge	USPAT; US-PGPUB; JPO	2003/02/10 11:40
31	100	((baffle adj plate) and (chamber adj wall)) and gap	USPAT; US-PGPUB; JPO	2003/02/10 11:53
32	0	((baffle adj plate) and (chamber adj wall)) and (gap adj measure)	USPAT; US-PGPUB; JPO	2003/02/10 11:53